

Notice of References Cited	Application/Control No. 09/544,289	Applicant(s)/Patent Under Reexamination HIYOSHI, TAKAYUKI	
	Examiner Hai C. Pham	Art Unit 2861	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,121,993	09-2000	Maekawara et al.	347/236
	B	US-			
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FOREIGN PATENT DOCUMENTS

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